

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Seungmoo Choi, et al.

Serial No.:

10/038,734

Filed:

December 31, 2001

For:

METHOD FOR FABRICATING MOS DEVICE WITH

HALO IMPLANTED REGION

Grp./A.U.:

2812

Examiner:

Booth, Richard A.

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450, on

Sir:

## AMENDMENT UNDER 37 C.F.R. § 1.111

In response to the Examiner's Action mailed June 27, 2002, and subsequent Office Communications dated December 27, 2002 and May 8, 2003, the Applicants respectfully request reconsideration of the above-identified application in view of the following amendments and remarks.